Dated: \_///0/03

Docket No.: 02830/100I079-US1

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e Patent Application of:

Fred J. Cadieu

Application No.: 10/051,211

Filed: January 16, 2002

For: A METHOD FOR MAKING FILMS

UTILIZING A PULSED LASER FOR ION

INJECTION AND DEPOSITION

Confirmation No.: 7210

Art Unit: 1763

Examiner: Richard R. Bueker

## RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In the Office Action mailed October 16, 2003 (Paper No. 6), the Examiner has required restriction between:

- I. Claims 15-32 and 40, drawn to a PLD apparatus having a confinement magnet device and a deflection magnet device positioned to deflect material discharged from the confinement magnet device; and
- II. Claims 33-39, drawn to a PLD apparatus having a deflection magnet member provided with a laser access port.

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Applicant hereby provisionally elects Group I (a PLD apparatus having a confinement magnet device and a deflection magnet device positioned to deflect material discharged from the confinement magnet device), claims 15-32 and 40 for continued examination. Applicant hereby reserves the right to continue prosecution of the non-elected claims in a divisional application.

It is believed that the present communication is fully responsive to the outstanding Office Action.

Dated: November 10, 2003

Respectfully submitted

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